Surface Analysis Technology Vacuum Components SP&CS°

Surface Analysis System Software

Computer Technology

Defined Area XPS with the PHOIBOS Analyzer using an Iris Aperture

Application Notes

In many applications photoelectrons emitted by the sample holder can lead to incorrect results. To suppress these photoelectrons, the PHOIBOS analyzer has a variable iris aperture at the front of the lens. By closing the iris photoelectrons from the surrounding can be eliminated (see Fig. 1).



The intensity-position function for such an analyzer is in general a Gaussian function but with superimposed higher intensities in the tail regions. By the use of the iris aperture these intensities can be suppressed. The low tail intensity forms a disc where the integrated intensity can reach the same order of magnitude like the intensity of the peak itself. By using the iris aperture, the "tail" intensities will primarily be suppressed.

The optimum settings for the iris aperture depend on the slit size and the desired quality of the analysis area.



Fig. 1: Simulation of intensity-position function

Fig. 2: Sample covered by molybdenum aperture

To demonstrate the effect of the iris aperture a polycristalline silver sample ($12\text{mm} \times 15\text{mm}$) was covered by a molybdenum plate with 10 mm hole in it. This would represent a sample in its holder. This sample was irradiated by X-ray source (Mg K α , 300W). The emission angle was 0°. Photoemission spectra of the Ag $3d_{5/2}$ and Mo $3d_{5/2}$ region were recorded at different iris openings.

		S P	ECS	S	
Resolution (eV)	0.85	0.90	1.00	1.40	Tab. 1: Iris setting 20
Ag 3 <i>d</i> _{5/2} (kcps)	960	1460	3100	7000	mm, intensity of Mo
Mo 3 <i>d</i> / _{5/2} (kcps)	12	16	37	105	uiways < 570
Resolution (eV)	0.85	0.90	1.00	1.40	Tab. 2: Iris setting 15
Ag 3 <i>d</i> _{5/2} (kcps)	800	1230	2560	5840	mm, intensity of Mo
Mo 3 <i>d</i> _{5/2} (kcps)	<1	<1	2	3	unity < 0.5 /0



Fig. 3: Ag and Mo intensities (weighted with sensitivity) versus Iris setting

Iris \varnothing

Iris \emptyset

By closing the Iris aperture to diameters in the acceptance angle region of the lens mode (<20 mm, see table), one can use the Iris aperture to limit the acceptance angle as well. The angular acceptance of the Magnification Modes can be continuously adjusted between ±1° and $\pm 6^{\circ}$ while keeping the acceptance area on the sample nearly constant.

Angle	(HM)	(MM)	(LM)
±1°	3 mm	3 mm	4 mm
±2°	6 mm	6 mm	8 mm
±3°	9 mm	9 mm	12 mm
±4°	12 mm	12 mm	
±5°	15 mm	15 mm	
±6°	18 mm		

Iris Ø

SPECS GmbH Surface Analysis and Computer Technology Voltastrasse 5 13355 Berlin Germany

Phone: +49 30 467824-0 Fax: +49 30 4642083 E-mail: support@specs.de http://www.specs.de



Acceptance

Fig. 4: Spectrum of Si 2s excited by Mg K_{α} using a PHOIBOS 150 MCD-9 analyzer. The angular resolution was set with the Iris to 1° (data with courtesy of T. Matsushita, A. Agui and A. Yoshigoe, Spring-8, Japan)

Surface Competence i n A nalysis